

Electron Microscopy II

- Transmission Electron Microscopy (TEM)
- Scanning Transmission Electron Microscopy (STEM)
- Scanning Electron Microscopy (SEM)

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200 nm

Electron Microscopy Methods

Transmission Electron Microscopy (TEM)

- Bright / Dark Field (BF/DF)
- High-Resolution Transition Electron Microscopy (HRTEM)
- Energy-Filtered (EFTEM)
- Electron Diffraction (ED)

Scanning Transmission Electron Microscopy (STEM)

- Bright / Dark Field (BF/DF-STEM)
- High-Angle Annular Dark Field (HAADF-STEM)

Analytical Electron Microscopy (AEM)

- X-ray Spectroscopy
- Electron Energy-Loss Spectroscopy (EELS)
- Electron Spectroscopic Imaging (ESI)

Scanning Electron Microscopy (SEM)

- Secondary Electrons (SE)
- Back-Scattered Electrons (BSE)

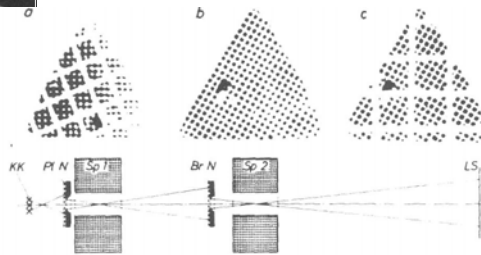
Development of the First Transmission Electron Microscope



1927 *Hans Busch*: Electron beams can be focused in an inhomogeneous magnetic field.

1931 *Max Knoll and Ernst Ruska* built the first TEM.

1986 Nobel prize for *Ruska*

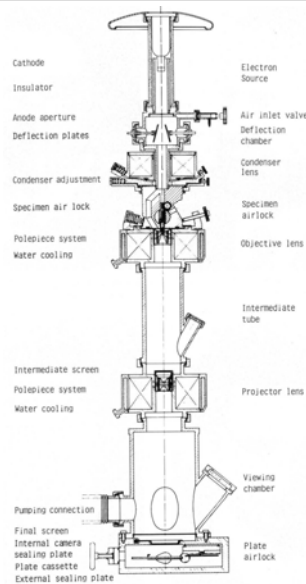


a) Einstufiges Bild eines Platin-Netzes vor Spule 1 durch Spule 1; M 130 : 1
 b) Einstufiges Bild eines Bronze-Netzes vor Spule 2 durch Spule 2; M 48 : 1
 c) Zweistufiges Bild des Platin-Netzes vor Spule 1 durch Spule 1 und Spule 2; M 174 : 1
 zusammen mit dem einstufigen Bild des Bronze-Netzes vor Spule 2; M 48 : 1

Knoll, Ruska, *Z. Phys.* **78** (1932) 318

History of Electron Microscopy

1938 First Siemens Electron Microscope (Resolution ca. 13 nm)

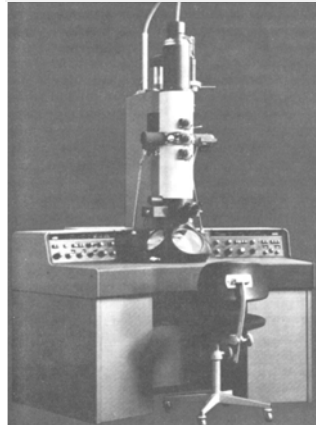


History of Electron Microscopy

Transmission Electron Microscopes



1939: first TEM serially produced by Siemens
resolution ca. 7 nm



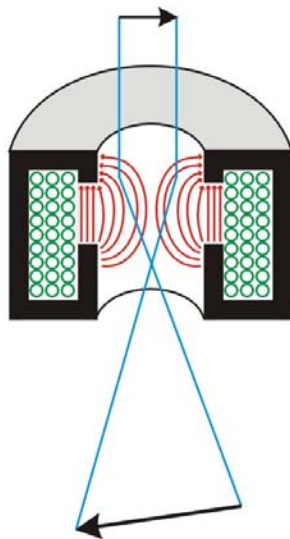
~1970: HRTEM
Philips EM400, V = 120 kV
resolution ca. 0.35 nm



~1990
Philips CM30, V = 300 kV
resolution ca. 0.2 nm

History of Electron Microscopy

Magnetic Lens



An electron in a magnetic field (here: inhomogeneous, but axially symmetric) experiences the Lorentz force F :

$$F = -e (E + v \times B)$$

$$|F| = evB \sin(\nu, B)$$

E : strength of electric field

B : strength of magnetic field

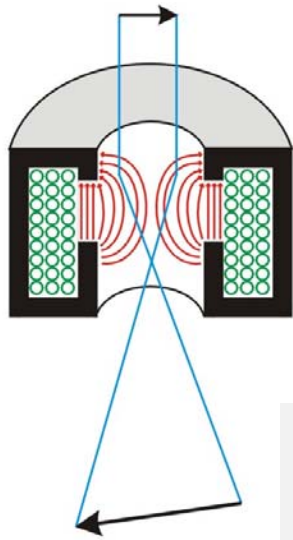
e/v : charge/velocity of electrons

Magnetic lenses

- manipulate the electron beam
- form an image of the object

Transmission Electron Microscopy

Magnetic Lens



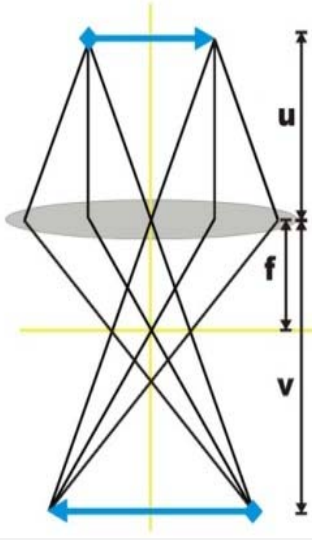
Object plane

Lens

Back focal plane

Lens problems:
spherical aberation C_s
chromatic aberation C_c
astigmatism

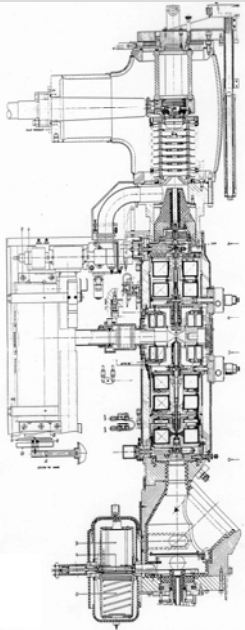
Light optical analogue




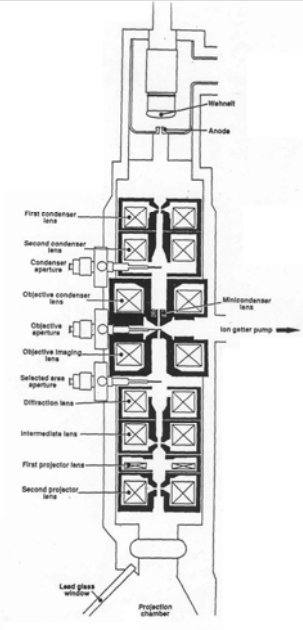
Lens equation: $1/u + 1/v = 1/f$
Magnification $M = v/u$

Transmission Electron Microscopy

Cross-Section of the Column of a CM30 Microscope







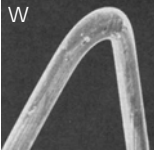
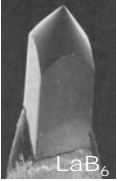
Labels in schematic:
Waholt, Anode, First condenser lens, Second condenser lens, Condenser aperture, Objective condenser lens, Objective aperture, Objective imaging lens, Selected area aperture, Diffraction lens, Intermediate lens, First projector lens, Second projector lens, Microcondenser lens, Ion getter pump, Lead glass window, Projection chamber.

Transmission Electron Microscopy

Electron Guns

Thermoionic Guns

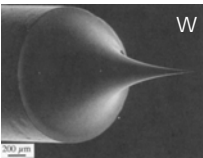
Electron emission by heating

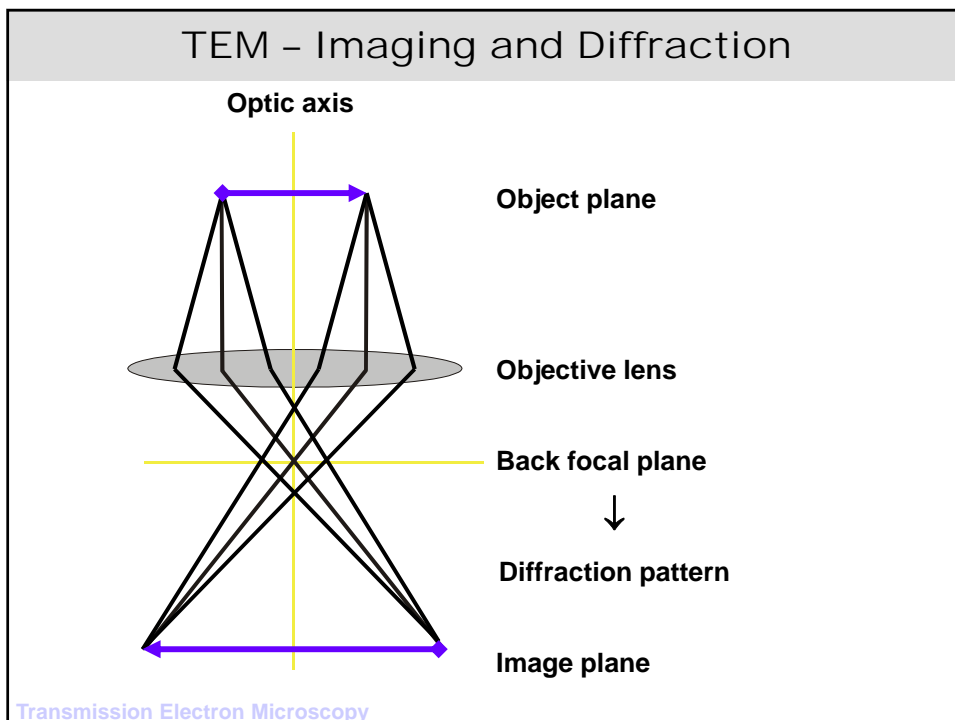
Properties	W	LaB ₆	FEG
Work function / eV	4.5	2.4	4.5
Temperature / K	2700	2000	(300-)1800
Energy spread / eV	3-4	1.5-3	0.4-1.5
Source size / nm	30000	5000	3-20
Maximum current / nA	1000	500	(30-)300
Brightness / A/m ² sr	10 ⁹	5x10 ¹⁰	10 ¹³
Lifetime / h	100	500	>1000

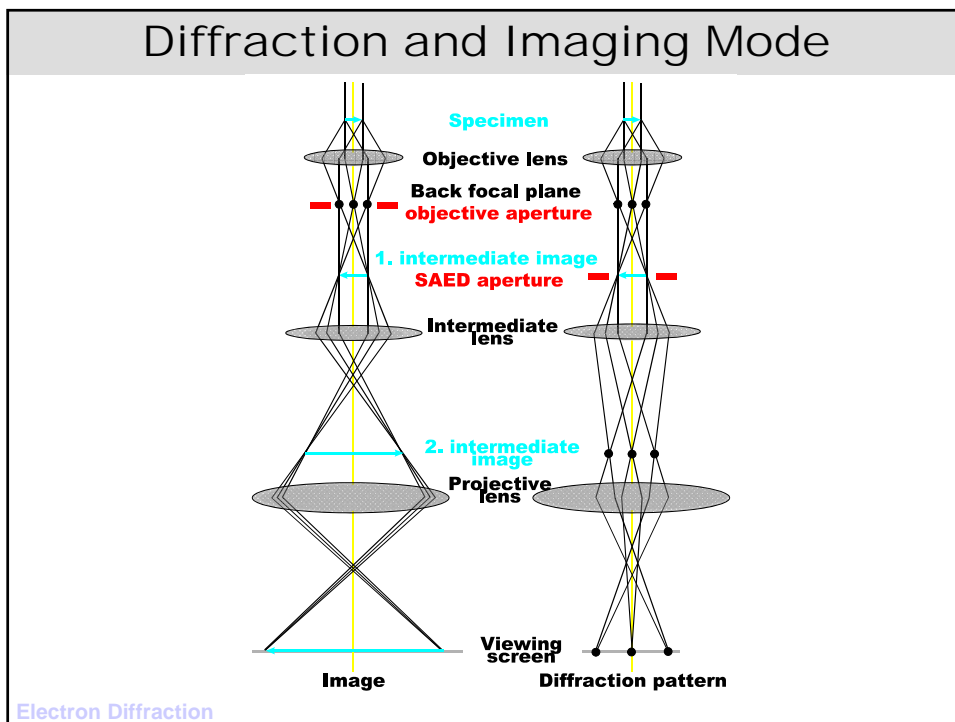
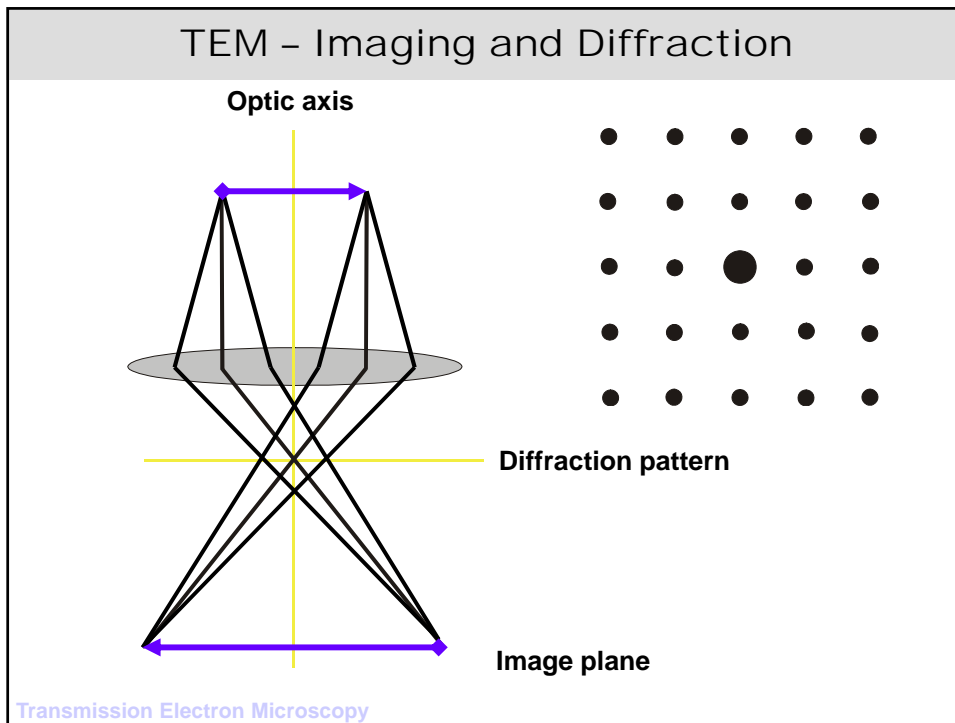
Field Emission Guns (FEG)

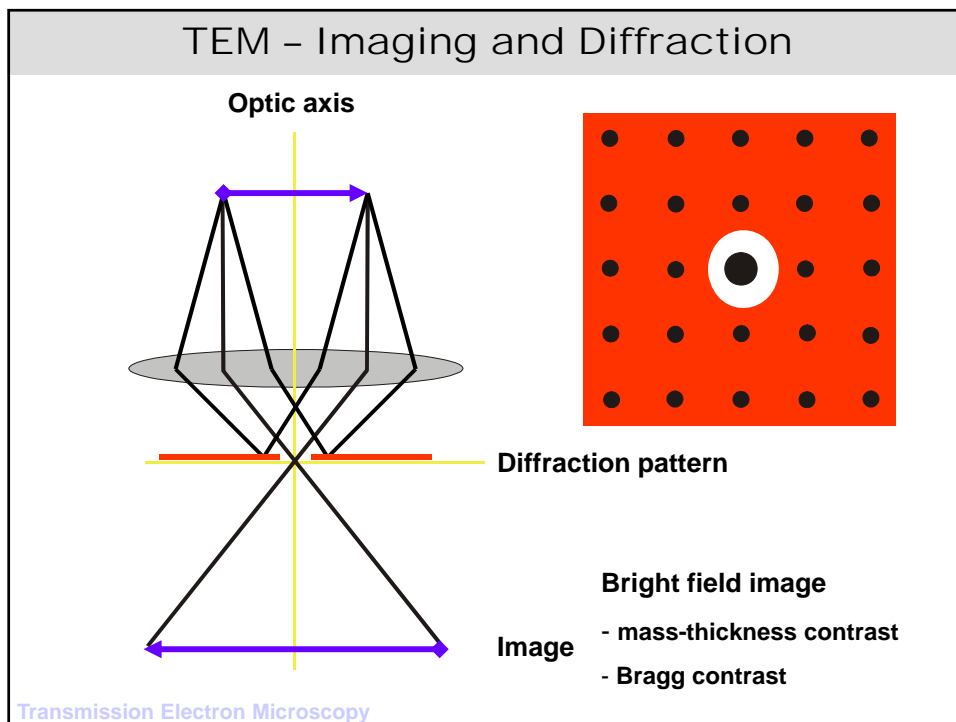
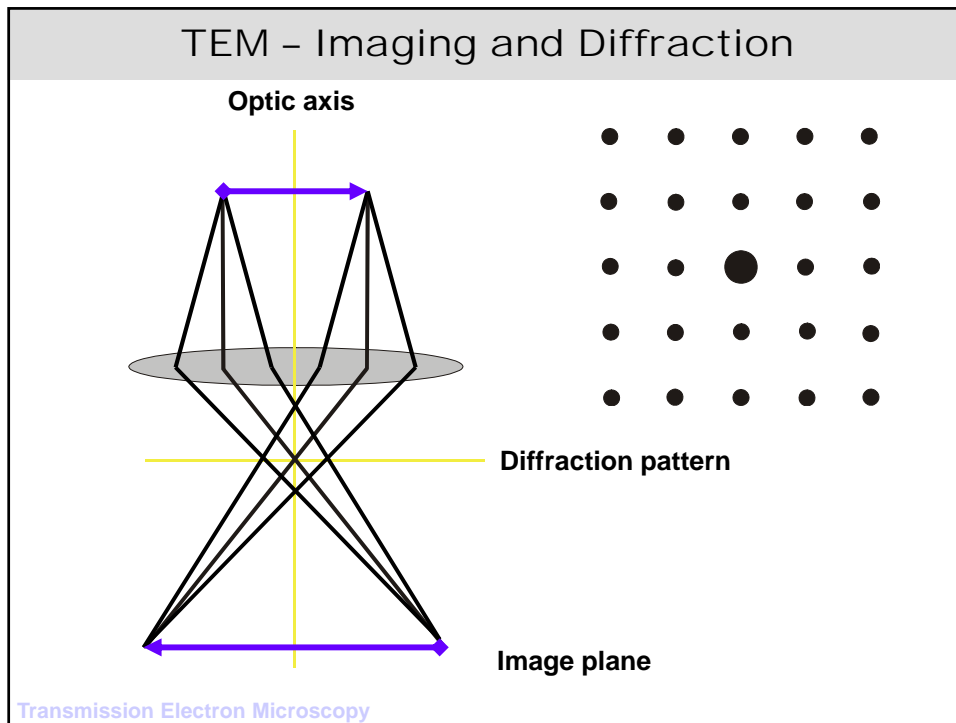
Electron emission by applying an extraction voltage

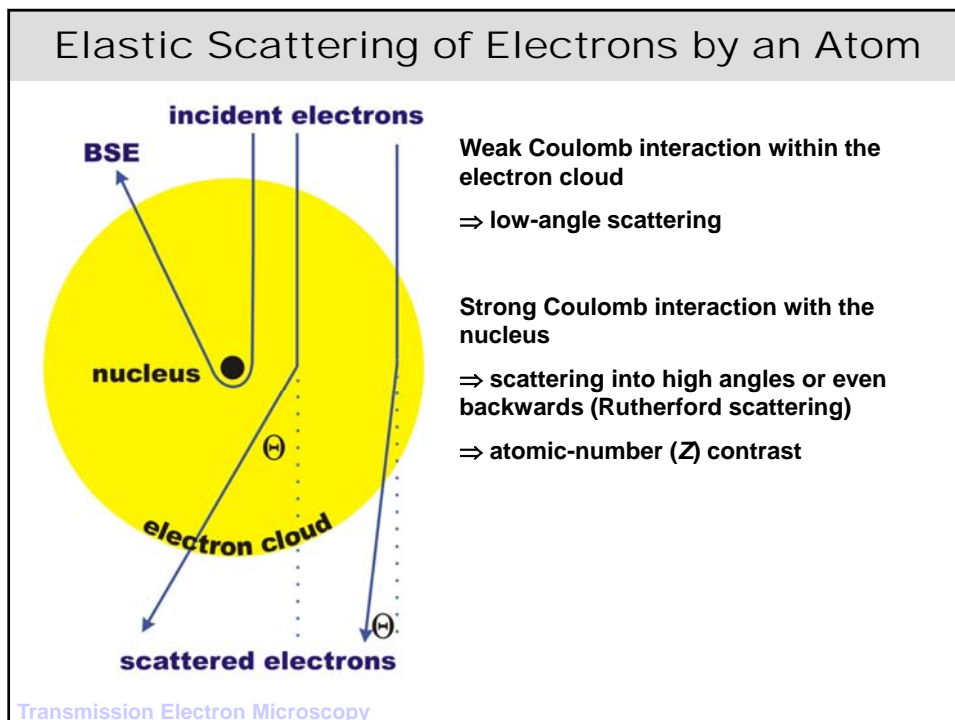
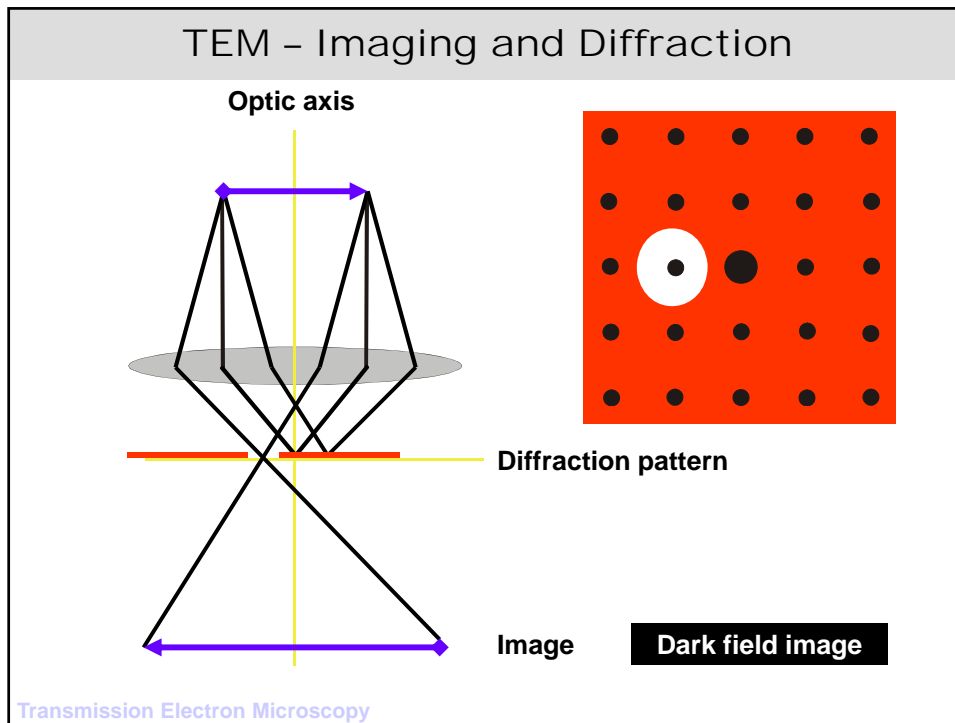


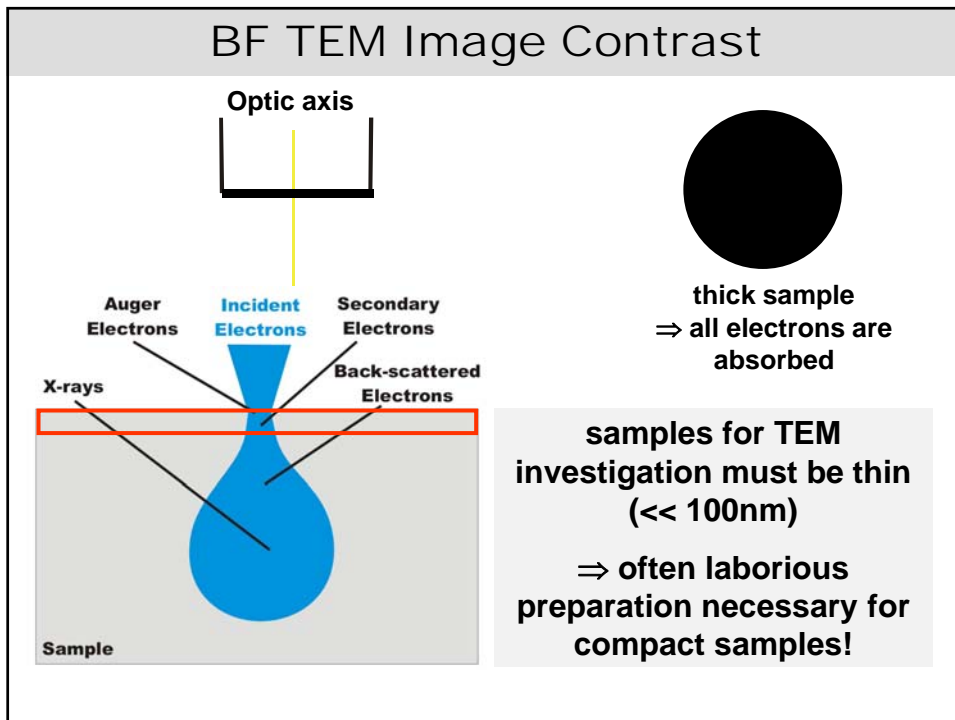
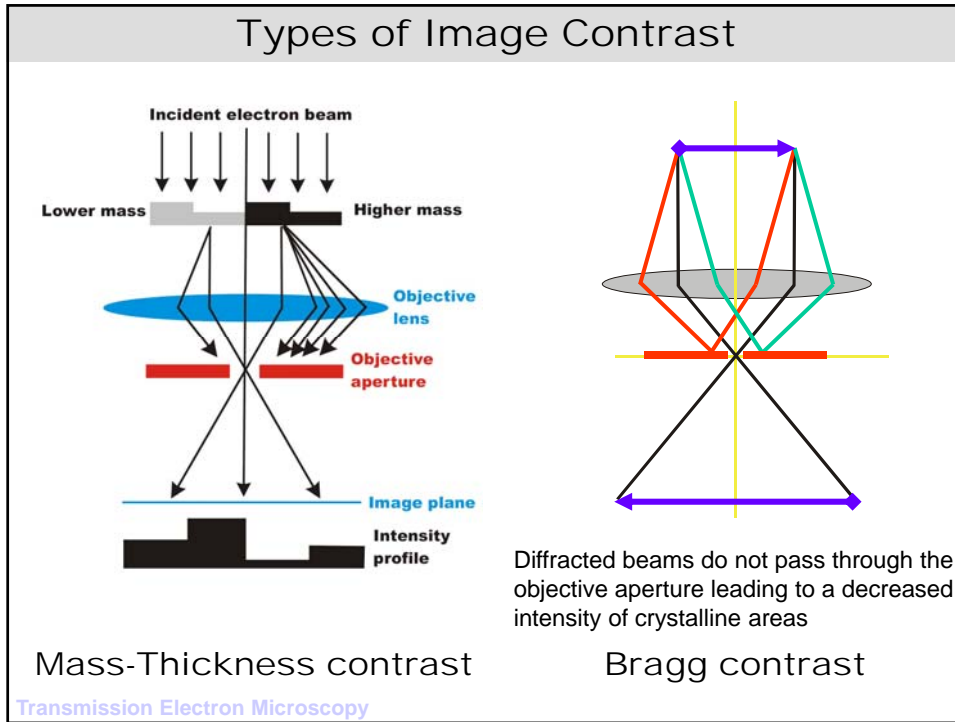
Transmission Electron Microscopy

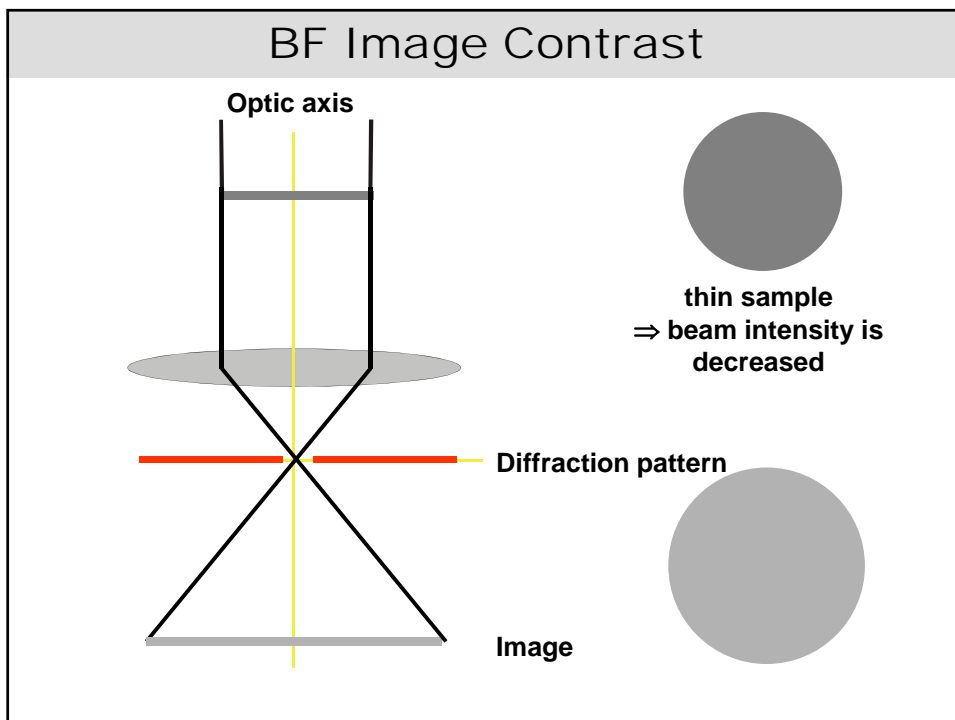
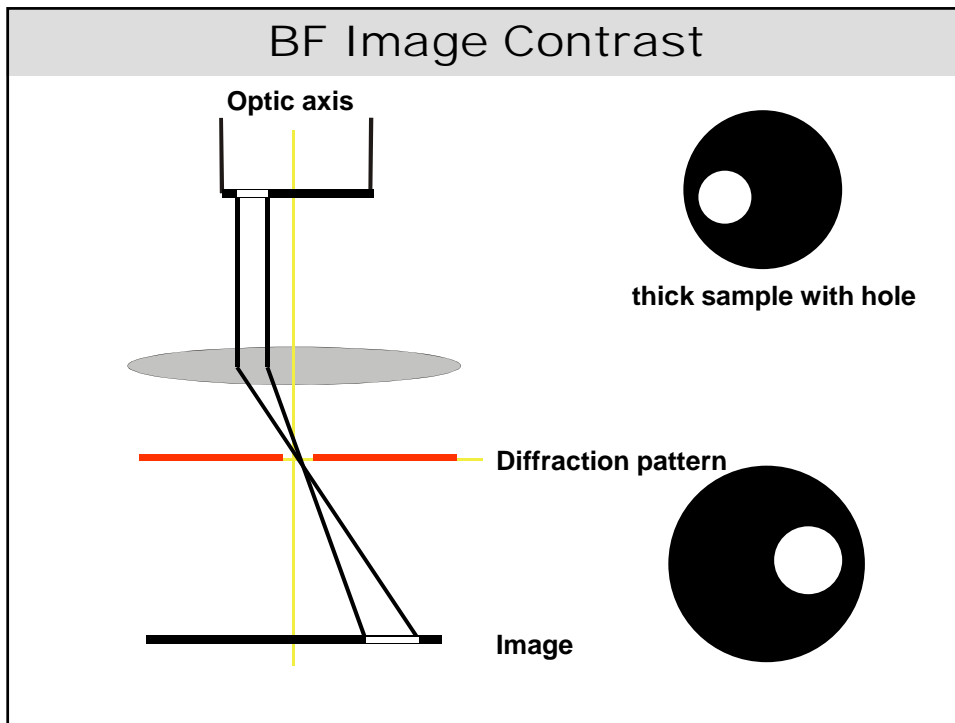


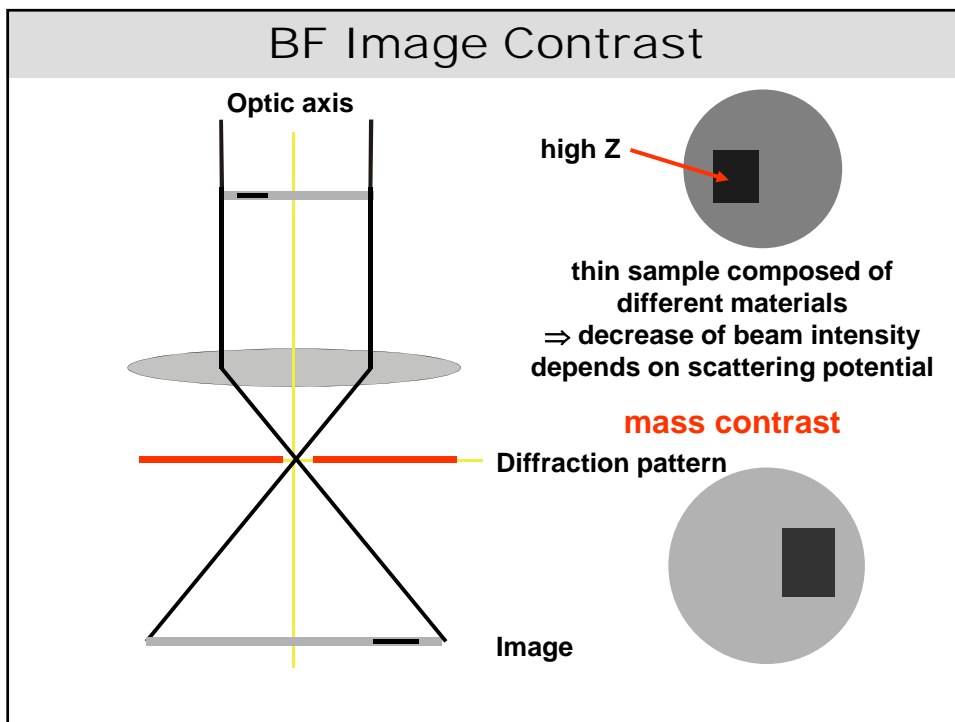
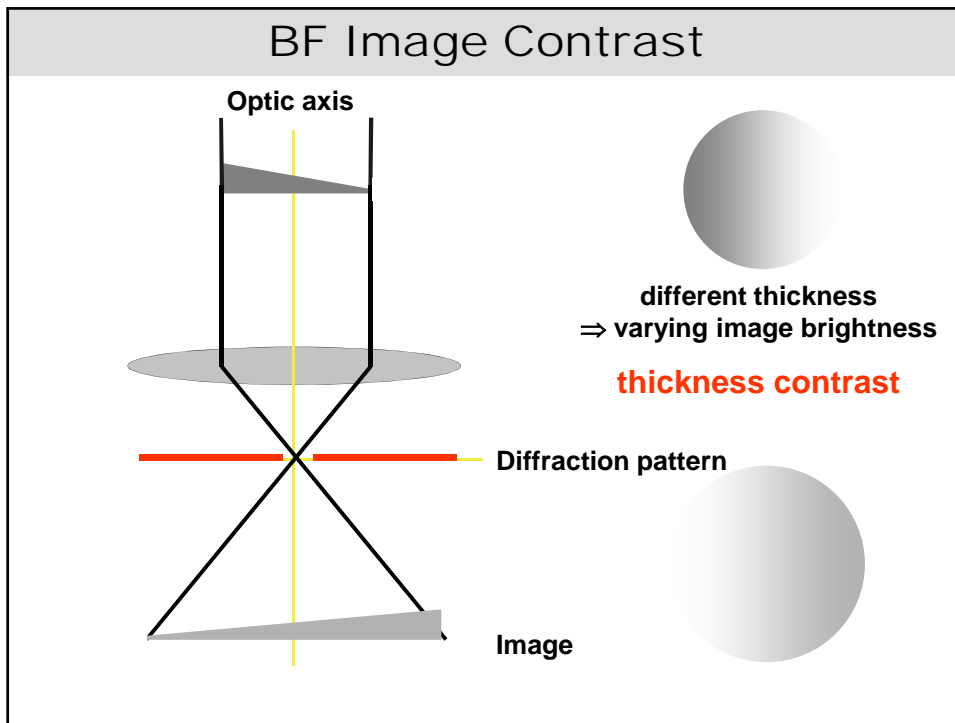




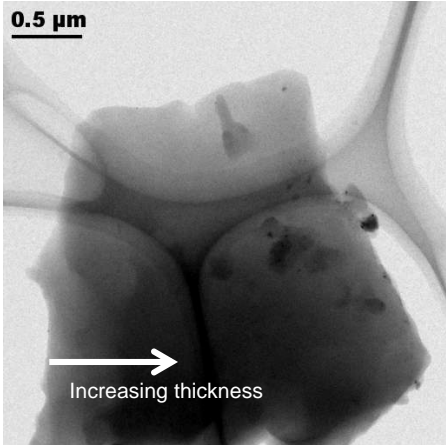








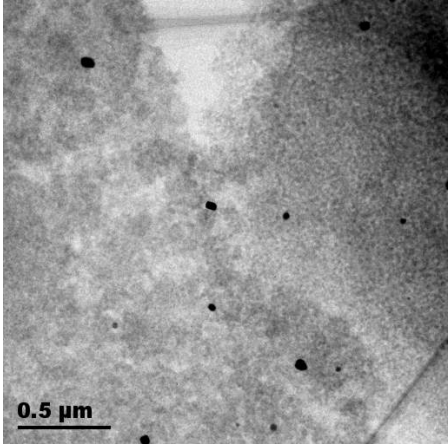
BF Images



0.5 μm

Increasing thickness

Amorphous SiO₂ on C foil
Mainly thickness contrast

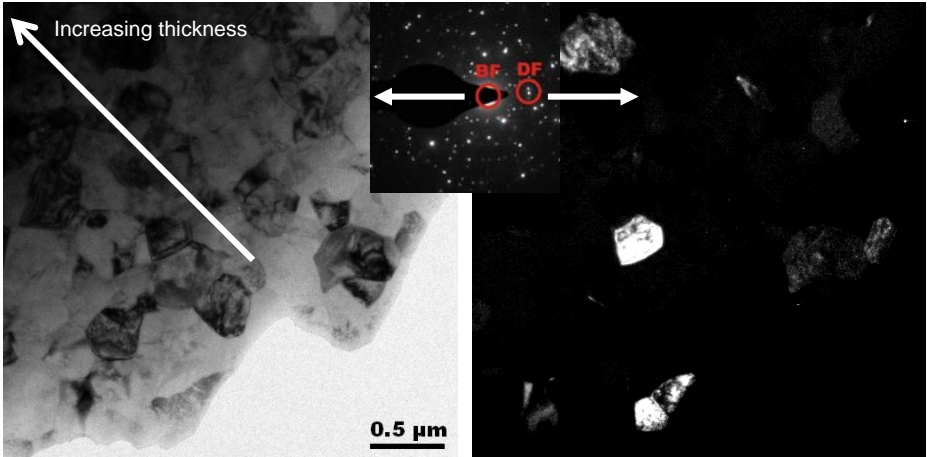


0.5 μm

Au particles (black) on TiO₂
Mainly mass contrast

Transmission Electron Microscopy

BF and DF Images

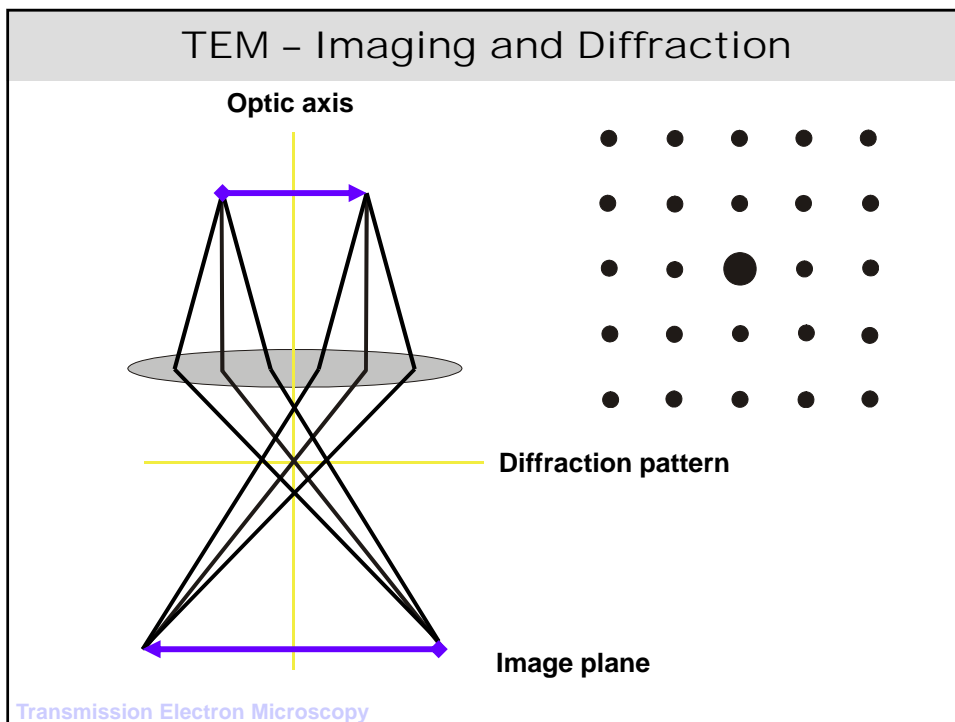
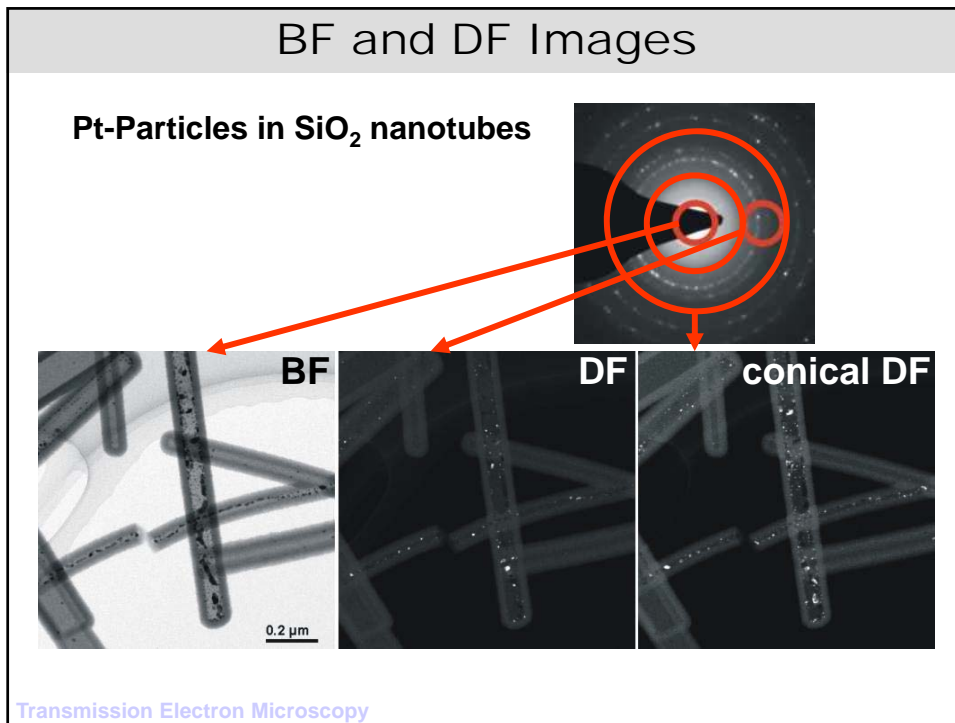


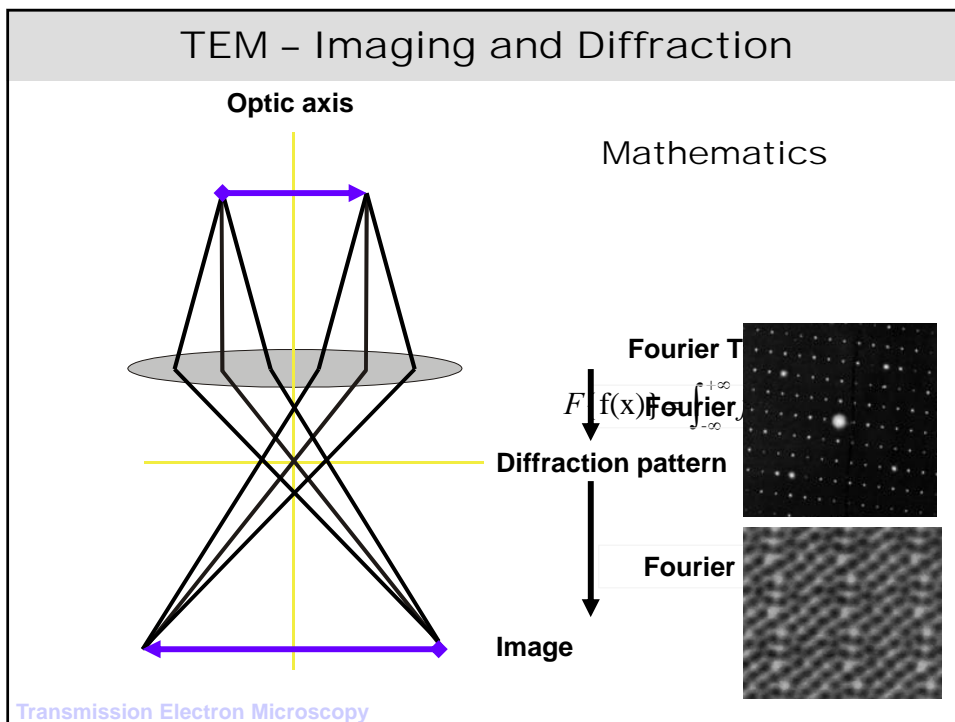
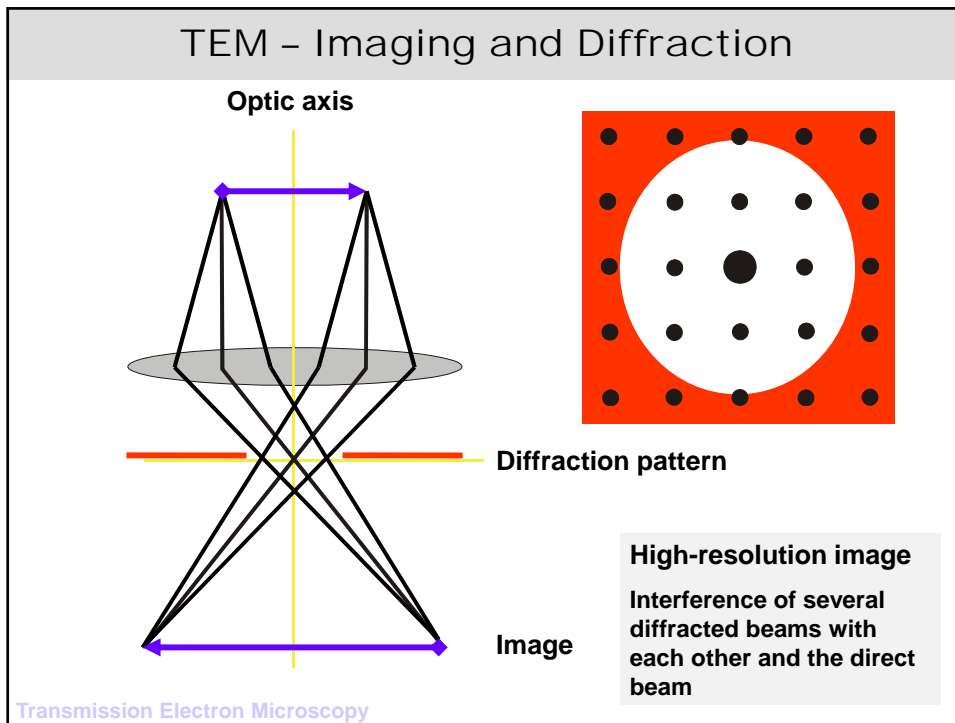
Increasing thickness

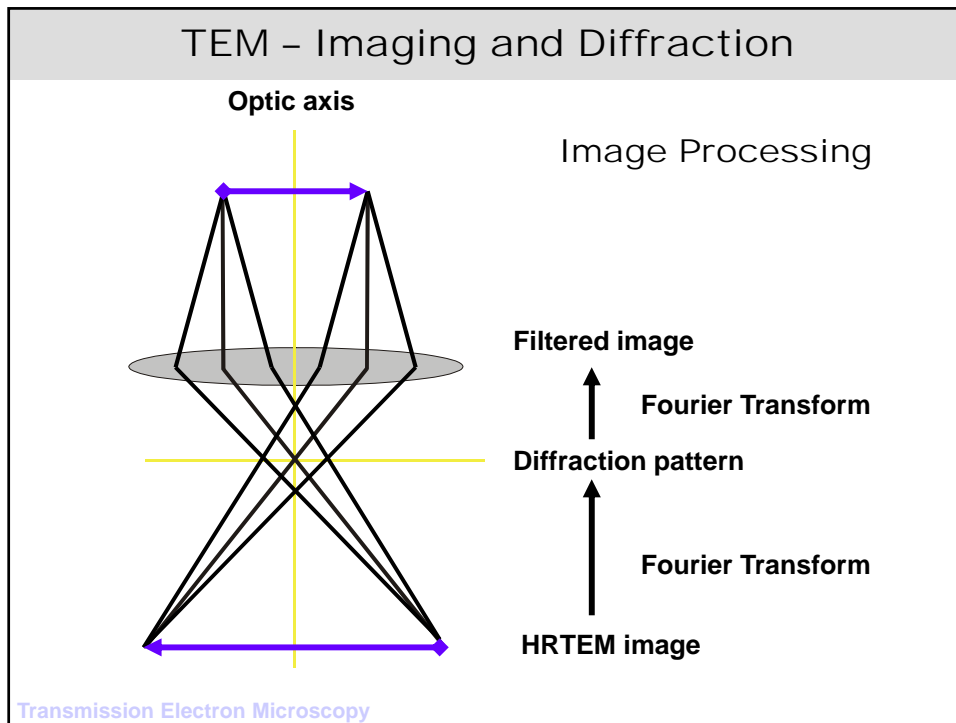
0.5 μm

ZrO₂ micro crystals; crystals orientated close to a zone axis appear dark in BF and bright in DF
Mainly Bragg contrast

Transmission Electron Microscopy







ED + HRTEM

a^*

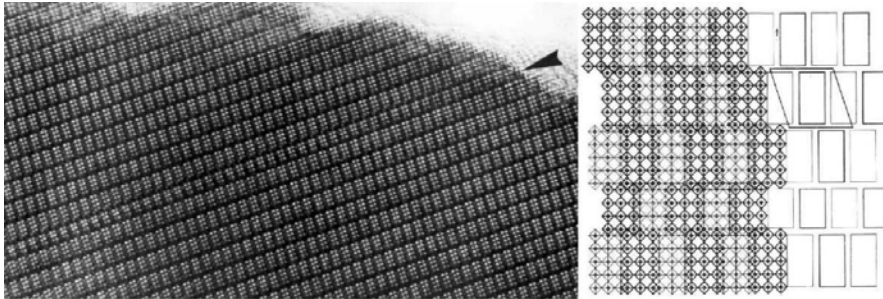
b^*

Nb₇W₁₀O₄₇ – threefold TTB superstructure

1 nm

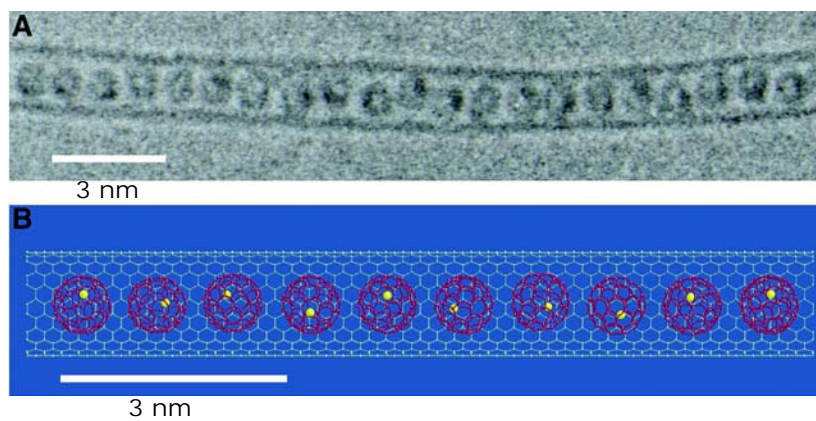
Transmission Electron Microscopy

HRTEM: Detection of Defects

Planar defect in $\text{ZnNb}_{14}\text{O}_{35}\text{F}_2$

Transmission Electron Microscopy

HRTEM: Imaging Single Atoms

 Gd@C_{82} in SWCNT

Transmission Electron Microscopy

Suenaga et al, *Science* **290** (2000) 2280

Transmission Electron Microscopy

Types of contrast:

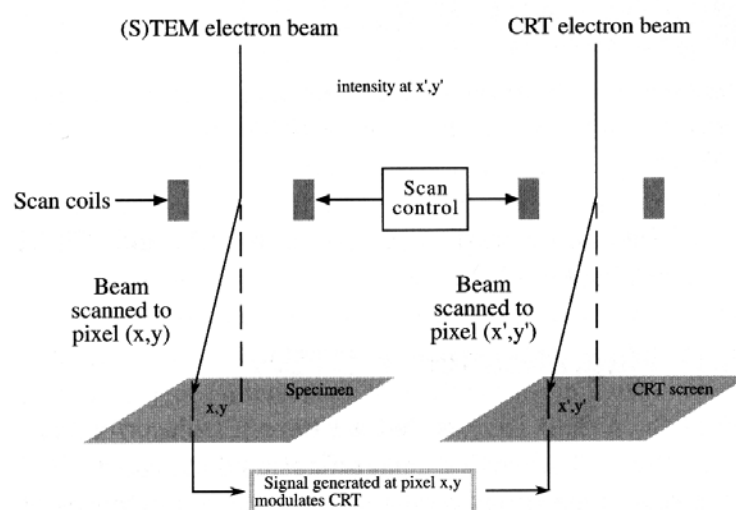
- Mass-thickness (BF/DF)
- Bragg (BF/DF)
- Phase (HRTEM; resolution limit $< 1 \text{ \AA}$)

Determination of

- Structure: HRTEM
- Defects: HRTEM, TEM
- Lattice constants and symmetry: ED
- Particle size: TEM, HRTEM

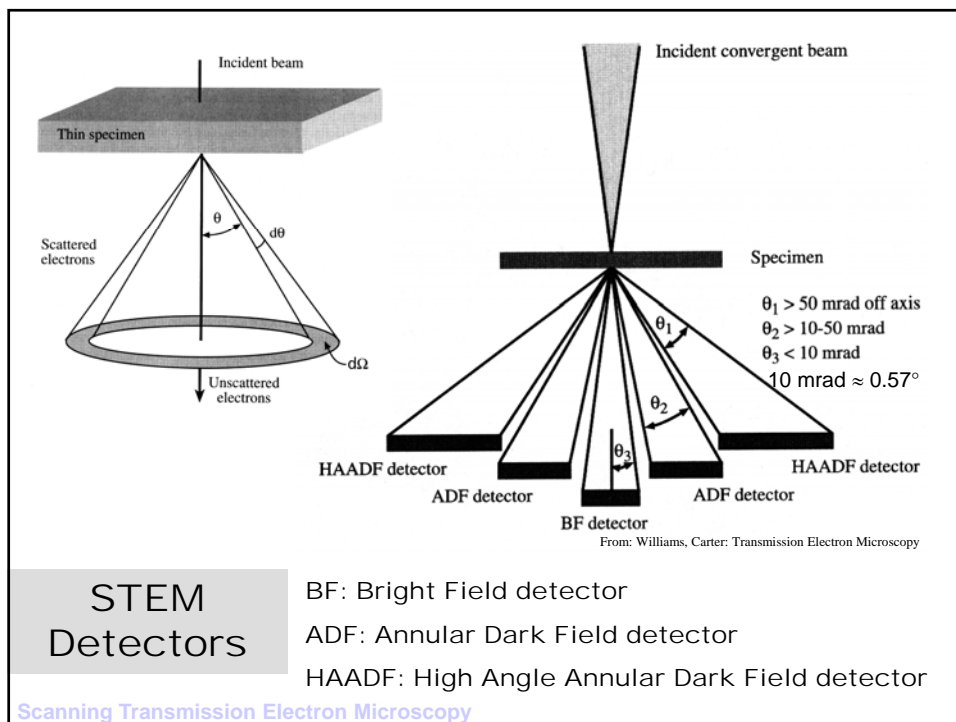
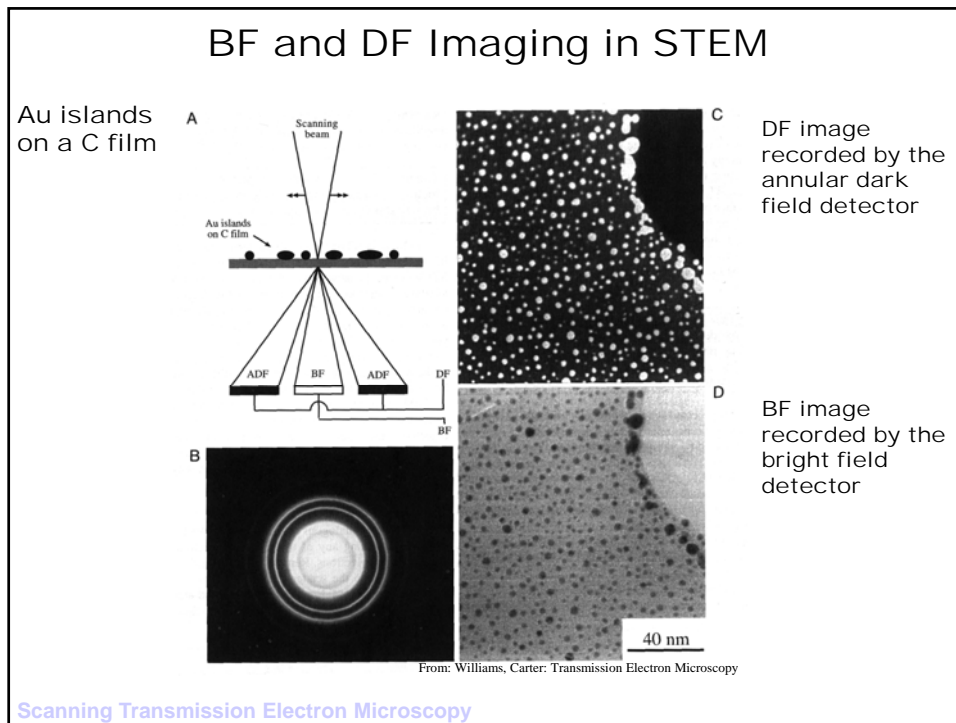
Transmission Electron Microscopy

Scanning Transmission Electron Microscopy (STEM)

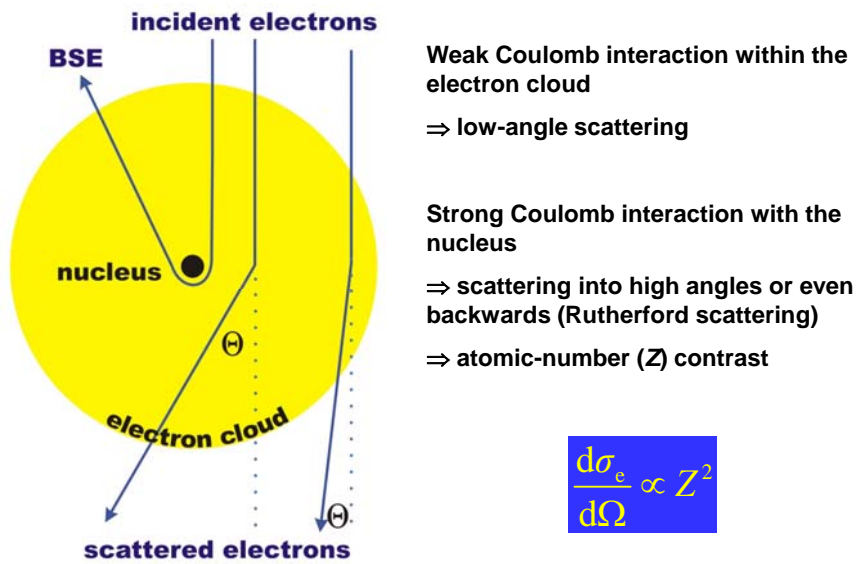


From: Williams, Carter: Transmission Electron Microscopy

Scanning Transmission Electron Microscopy



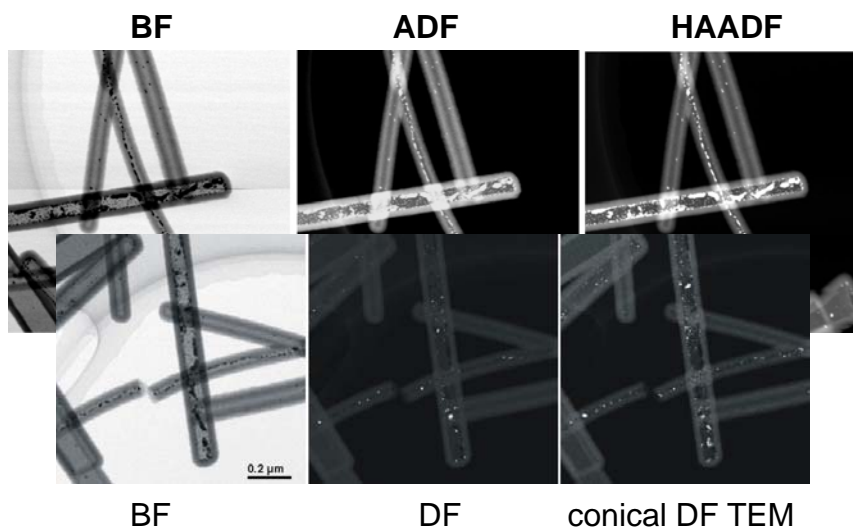
Scattering of Electrons at an Atom



Scanning Transmission Electron Microscopy

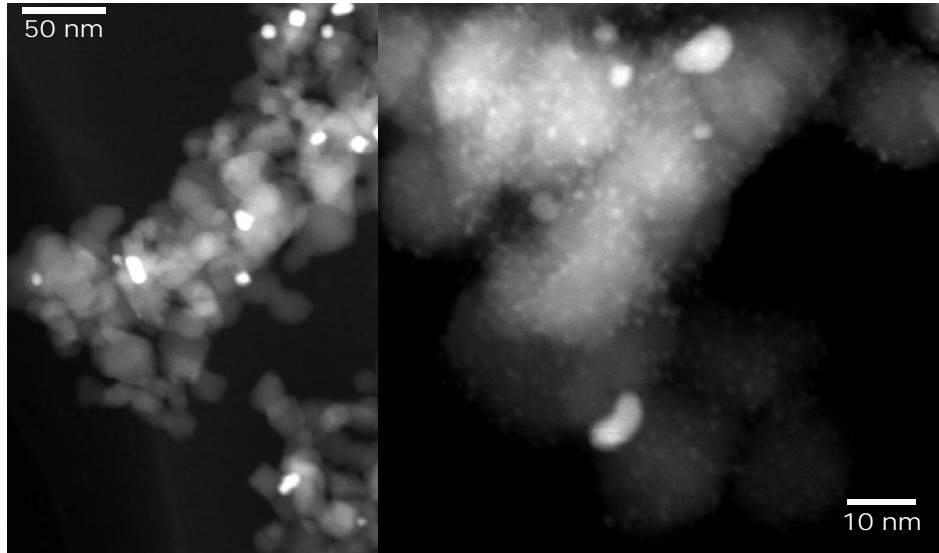
BF and DF Imaging in STEM

Pt particles in SiO₂ nanotubes



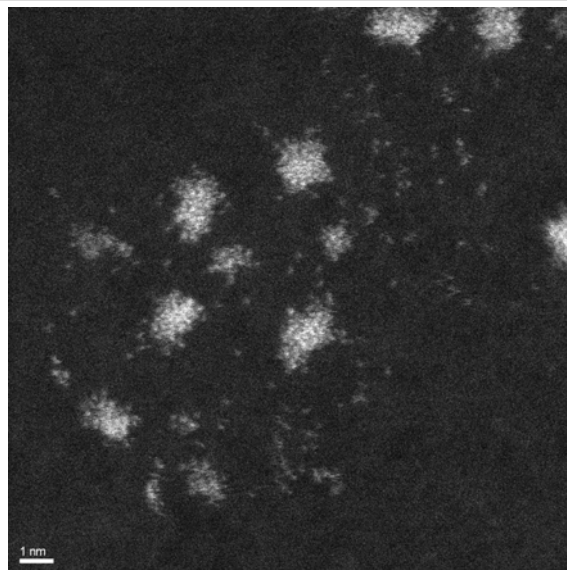
Scanning Transmission Electron Microscopy

HAADF-STEM or Z contrast Images of Au Particles on Titania



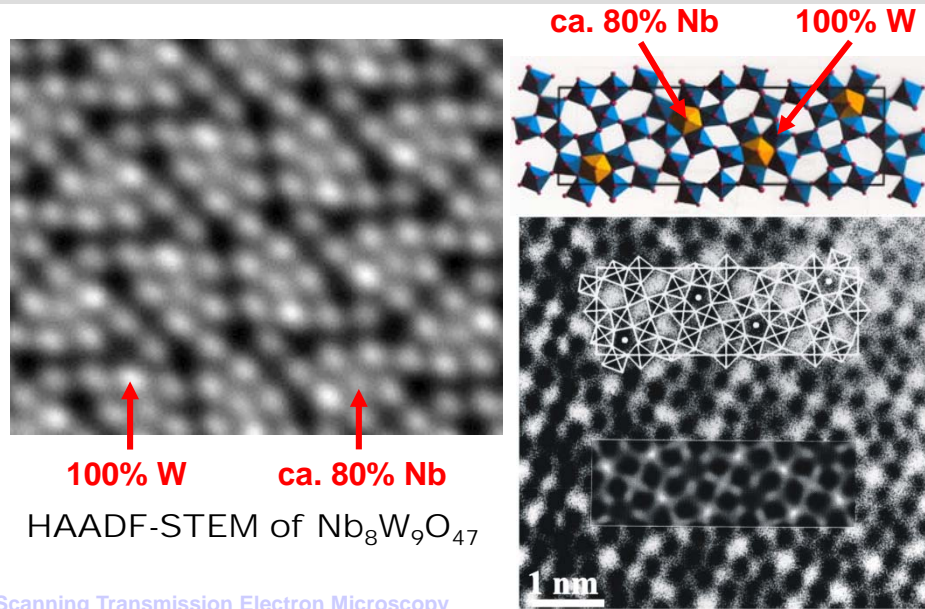
Scanning Transmission Electron Microscopy

HAADF-STEM or Z contrast Images of Pt Clusters and Atoms on Carbon



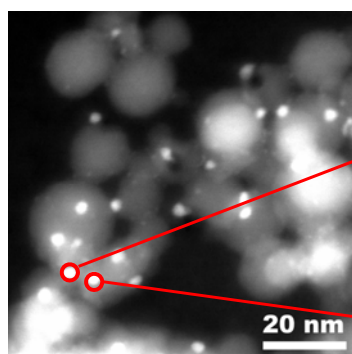
Scanning Transmission Electron Microscopy

Information about Elemental Distribution in HAADF-STEM or Z contrast images

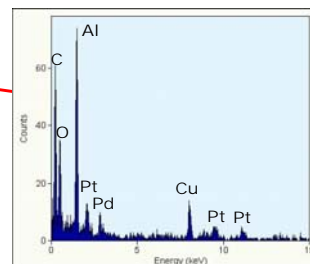
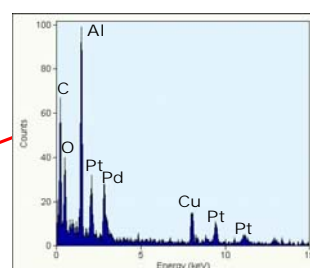


Pd and Pt supported on alumina: Size of the particles? Alloy or separated?

STEM + EDXS: Point Analyses



HAADF-STEM image



Scanning Transmission Electron Microscopy

Scanning Transmission Electron Microscopy

Contrast:

- Mass-thickness (BF/DF)
- Bragg (BF/DF)
- Z^2 (HAADF)

Determination of

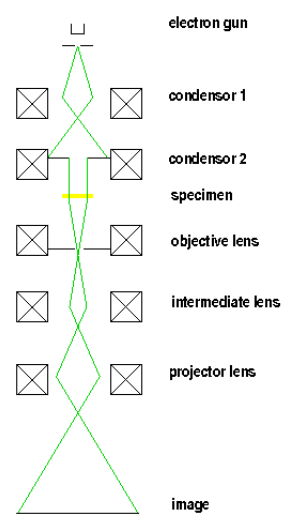
- Particles on support : HAADF
- Structure and defects : HR
- Chemical information : HAADF

Important: Combination with EDXS or EELS

Scanning Transmission Electron Microscopy

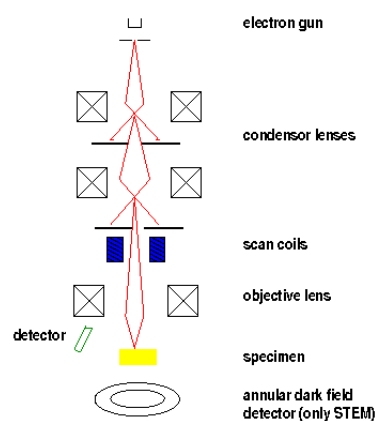
TEM versus STEM

Transmission (TEM)



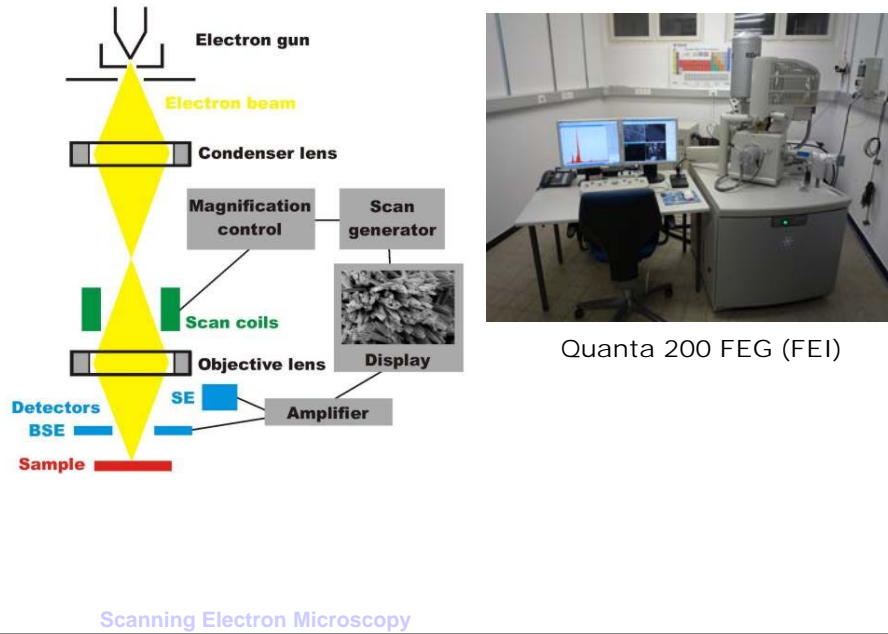
$$\text{Resolution: } \Delta x = 0.66 C_s^{1/4} \lambda^{3/4}$$

Scanning (SEM or STEM)

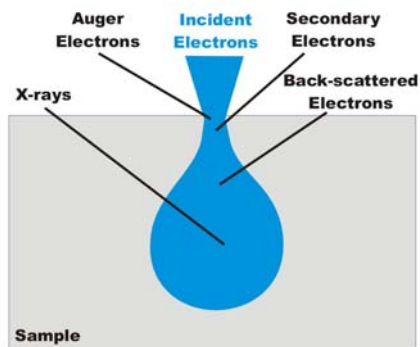


$$d = 0.41 C_s^{1/4} \lambda^{3/4}$$

Scanning Electron Microscopy (SEM)



Signals used in the SEM



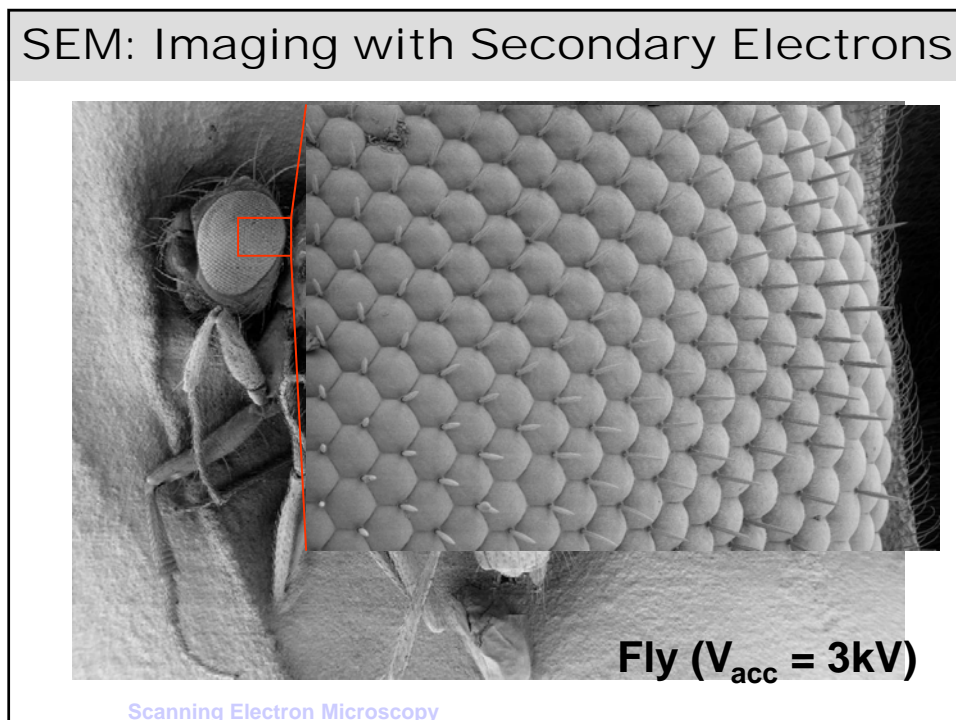
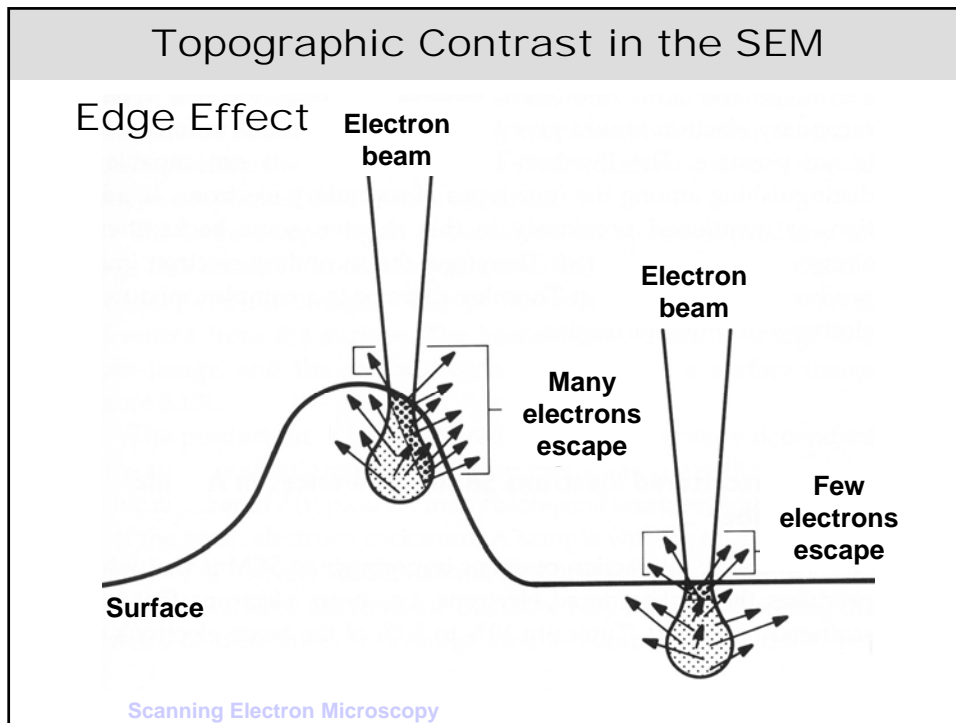
Secondary Electrons (SE)

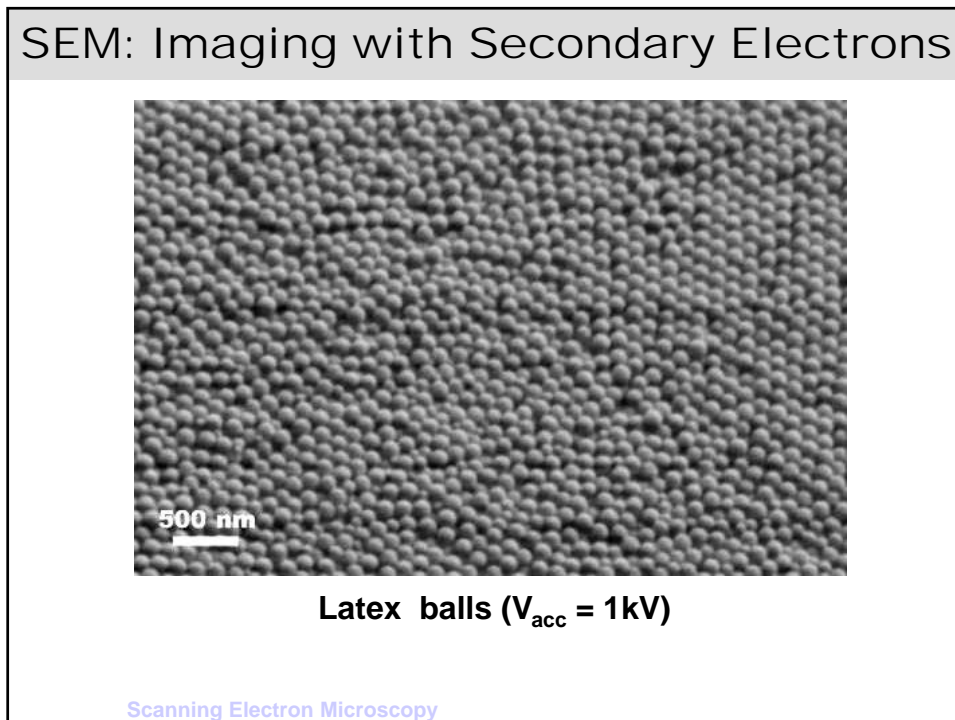
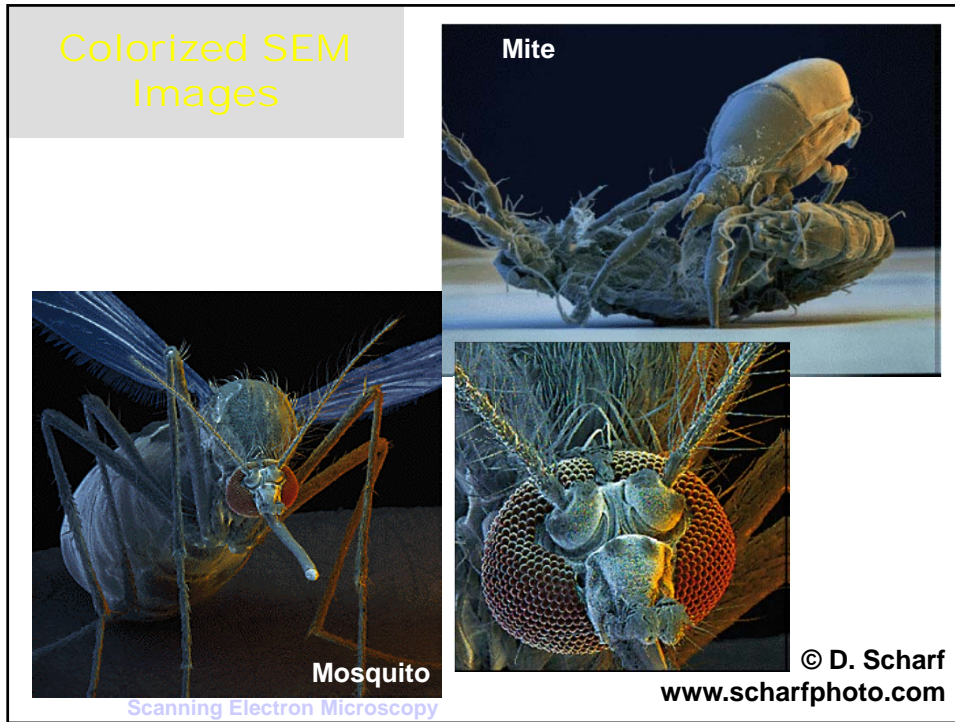
- low energy < 100 eV (result of inelastic interactions)
- information about topography and morphology
- escape only when generated close to the surface

Back-scattered Electrons (BSE)

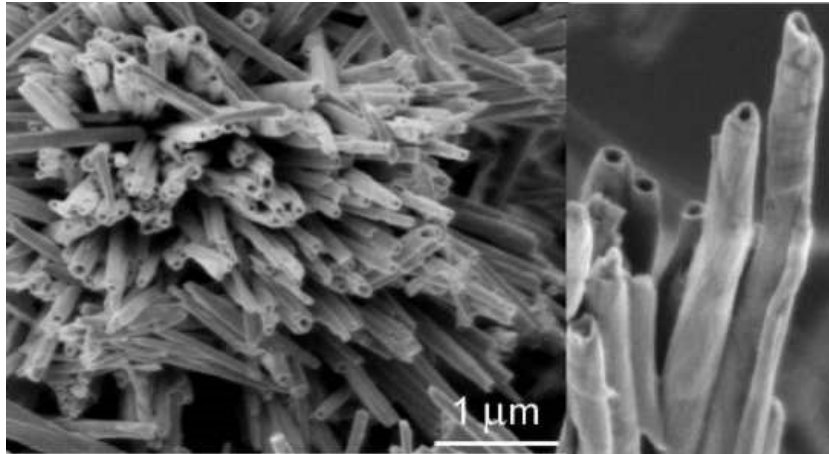
- high energy $\cong E_0$ (result of elastic interactions)
- morphology and chemical information

Scanning Electron Microscopy



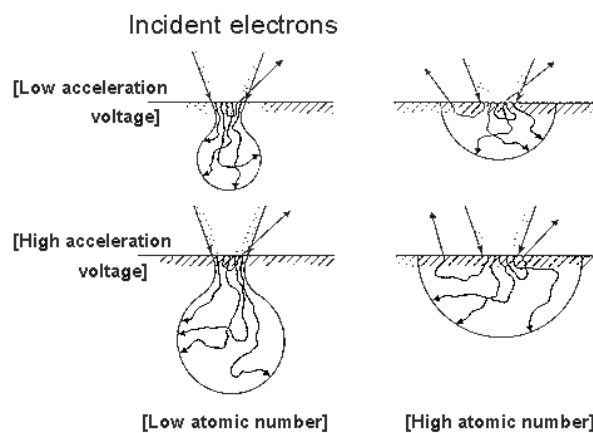


SEM: Imaging with Secondary Electrons

Vanadium oxide nanotubes ($V_{acc} = 1\text{kV}$)

Scanning Electron Microscopy

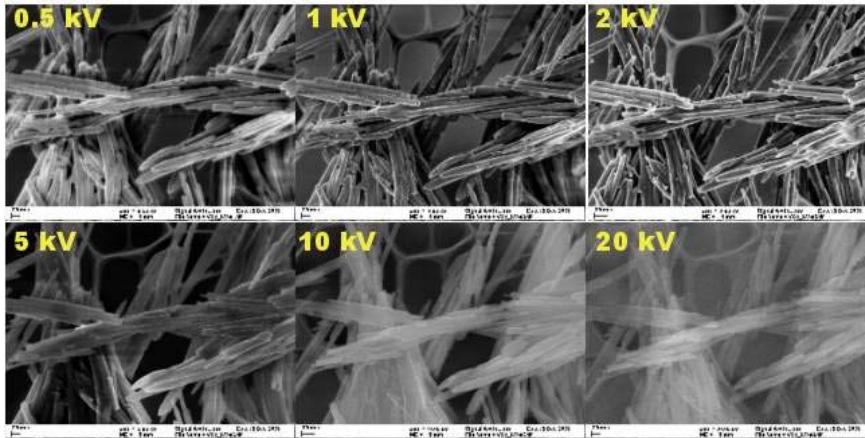
SEM: Dependence on Electron Energy

**Penetration depth of electrons in matter**

- increases with increasing V_{acc}
- decreases with increasing atomic number

Scanning Electron Microscopy

SEM: Dependence on Electron Energy



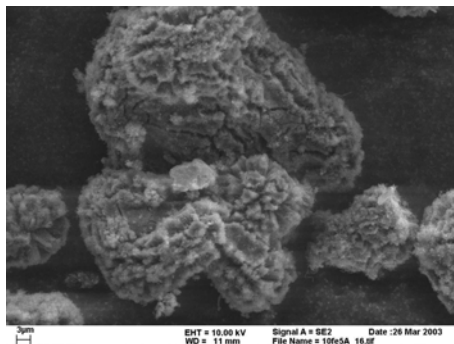
Resolution (Gemini 1530 FEG):

1 nm at 20 kV 1.5 nm at 10 kV
 2.5 nm at 1 kV 5 nm at 0.2 kV

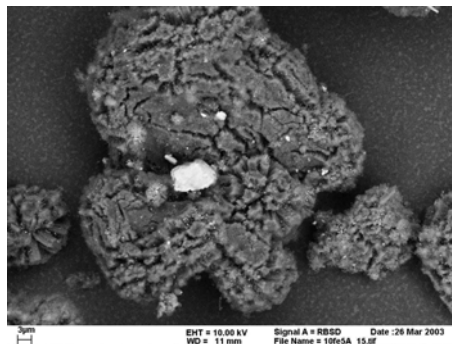
Scanning Electron Microscopy

SEM: Detection of SE versus BSE

Fe particles in C



Secondary electron detector

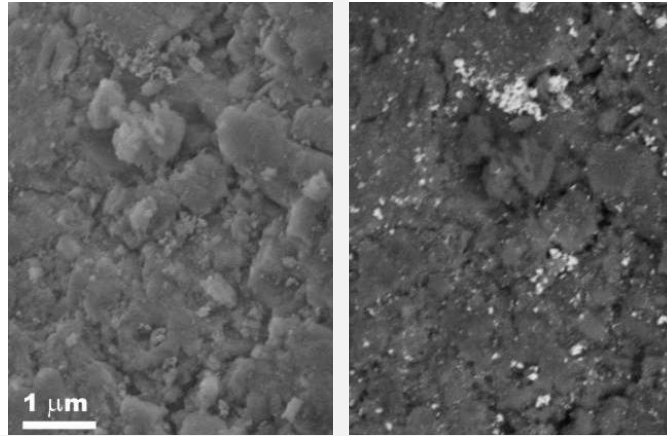


Backscattered electron detector
 Fe particles bright (Z contrast)

Scanning Electron Microscopy

SEM: Detection of SE versus BSE

Pt particles on alumina



Secondary electron detector

Backscattered electron detector

Pt particles bright (Z contrast)

Scanning Electron Microscopy

Scanning Electron Microscopy (SEM)

Detection of:

- Secondary electrons
- Back-scattered electrons

Determination of

- Morphology
- Surface topology
- Particles of heavy elements

Combination with EDXS

Scanning Electron Microscopy

**Script: *Interactions.pdf* on
www.microscopy.ethz.ch/downloads**

Textbooks:

**Williams, Carter, Plenum Press, New York, 1996:
*Transmission Electron Microscopy (available in chemistry library)***

**Thomas, Gemming, Springer, Berlin, 2014:
*Analytical Transmission Electron Microscopy – An Introduction
for Operators*
*Analytische Transmissionselektronenmikroskopie – eine
Einführung für den Praktiker***

Lecture: *Electron Microscopy* (each fall term)